

Application No. 10/586,593
Paper Dated April 2, 2008
Attorney Docket No. 4605-062147

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/586,593 Confirmation No. 1650
Applicants : MASATAKA NAKAHARA
Filed : July 19, 2006
Title : POLISHING METHOD AND POLISHING FILM FOR USE
IN THE POLISHING METHOD
Group Art Unit : 2874
Examiner : Not Yet Assigned
Customer No. : 28289

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

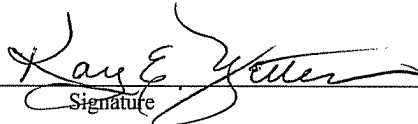
Sir:

Pursuant to the requirements of 37 C.F.R. §§ 1.56, 1.97, and 1.98, Applicant hereby submits this Information Disclosure Statement, which includes a completed Form PTO/SB/08a and one copy of each non-U.S. reference listed thereon.

The above-referenced application is the United States national phase of PCT Application No. PCT/JP2004/018387. A copy of the PCT International Search Report (ISR) was filed with the U.S. Patent & Trademark Office on July 19, 2006 as part of the national stage entry. A copy of an English-language translation of the International Preliminary Report on Patentability (IPRP) is attached for the Examiner's convenience.

I hereby certify that this correspondence is being electronically submitted to the United States Patent and Trademark Office on April 2, 2008.

04/02/2008
Date


Signature

Kay E. Yetter
Typed Name of Person Signing Certificate

The ISR cites U.S. Patent Application Publication No. 2003/0029095, Japanese Patent Application Publication Nos. JP 2003-211351, JP 2003-510446, JP 2000-263449, JP 2001-240849, JP 2004-268152 and JP 2004-055732 and PCT Application Publication No. WO 01/23485, listed on Form PTO/SB/08a. The attached copies of JP 2003-211351, JP 2000-263449, JP 2001-240849, JP 2004-268152 and JP 2004-055732 are accompanied by partial English-language translations. JP 2003-510466 corresponds to WO 01/23485 and US 2003/0029095.

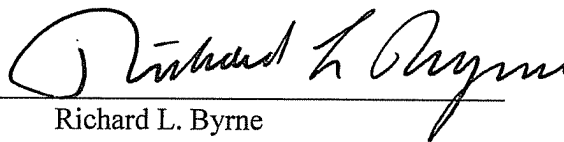
Japanese Patent Application Publication No. 9-248771, listed on Form PTO/SB/08a, is cited in the specification at page 1, lines 12-13. The attached copy of this reference is accompanied by a partial English-language translation.

Attached is a Notification for Reasons for Refusal for counterpart Japanese Application No. 2004-015237, which cites Japanese Patent Application Publication Nos. JP 2001-240849, JP 2000-326211, JP 2004-022804, JP 2003-211351 and JP 10-273648, listed on Form PTO/SB/08a. The attached copies of JP 2000-326211, JP 2004-022804 and JP 10-273648 are accompanied by English-language abstracts.

Pursuant to 37 C.F.R. § 1.97(b)(3), no fee is due for the submission of this Information Disclosure Statement, which is being filed before the mailing of a first Office Action on the merits. However, the Commissioner for Patents is hereby authorized to charge any additional fees which may be required to Deposit Account No. 23-0650. Please refund any overpayment to Deposit Account No. 23-0650.

Respectfully submitted,

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